

- Describe and illustrate nonparametric and graphical methods of analyzing and presenting accelerated life test data.
- Describe and illustrate maximum likelihood methods of analyzing and making inferences from accelerated life test data.
- Illustrate different kinds of data and ALT models.
- Discuss some specialized applications of accelerated testing.
- Describe pitfalls in accelerated testing.

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Based on the authors' text *Statistical Methods for Reliability Data*, John Wiley & Sons Inc. 1998.

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8h 5min

Example: Temperature-Accelerated Life Test on Device-A (from Hooper and Amster 1990)

Data: Singly right censored observations from a temperature-accelerated life test.

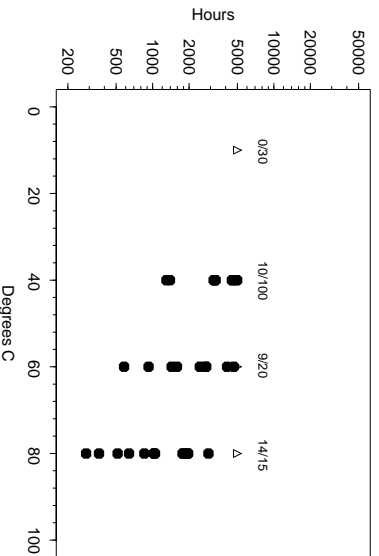
Purpose: To determine if the device would meet its hazard function objective at 10,000 and 30,000 hours at operating temperature of 10°C.

We will show how to fit an accelerated life regression model to these data to answer this and other questions.

Hours Versus Temperature Data from a Temperature-Accelerated Life Test on Device-A

Hours	Status	Number of Devices	Temperature °C	In Subexperiment Units	Failures
5000	Censored	30	10	30	0/30
1298	Failed	1	40	100	10/100
1390	Failed	1	40		
⋮	⋮	⋮	⋮		
5000	Censored	90	40		
581	Failed		60	20	9/20
925	Failed		60		
1432	Failed		60		
⋮	⋮	⋮	⋮		
5000	Censored	11	60		
283	Failed	1	80	15	14/15
361	Failed	1	80		
515	Failed	1	80		
638	Failed	1	80		
⋮	⋮	⋮	⋮		
5000	Censored	1	80		

Device-A Hours Versus Temperature (Hooper and Amster 1990)



ALT Data Plot

- Examine a scatter plot of lifetime versus stress data.
- Use different symbols for censored observations.

Note: Heavy censoring makes it difficult to identify the form of the life/stress relationship from this plot.

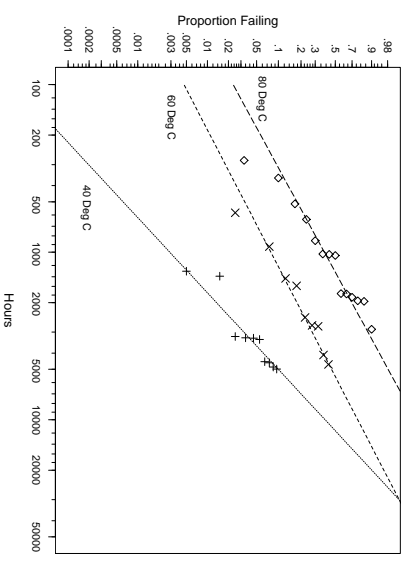
Strategy for Analyzing ALT Data

- For ALT data consisting of a number of subexperiments, each having been run at a particular set of conditions:
 - Examine the data graphically: Scatter and probability plots.
 - Use a multiple probability plot to study the data from the individual subexperiments.
 - Fit an overall model involving a life/stress relationship.
 - Perform residual analysis and other diagnostic checks.
 - Perform a sensitivity analysis.
- Assess the reasonableness of using the ALT data to make the desired inferences.

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Weibull Multiple Probability Plot Giving Individual Weibull Fits to Each Level of Temperature for Device-A ALT Data

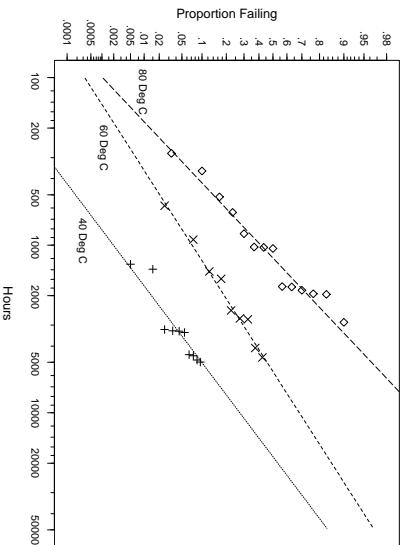
$$\Pr\{T(\text{temp}_i) \leq t\} = \Phi_{\text{sew}} \left[\frac{\log(t) - \beta t_i}{\sigma_i} \right], \quad i = 40, 60, 80$$



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Lognormal Multiple Probability Plot Giving Individual Lognormal Fits to Each Level of Temperature for Device-A ALT Data

$$\Pr\{T(\text{temp}_i) \leq t\} = \Phi_{\text{nor}} \left[\frac{\log(t) - \beta t_i}{\sigma_i} \right], \quad i = 40, 60, 80$$



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ALT Multiple Probability Plot of Nonparametric Estimates at Individual Levels of Accelerating Variable

- Compute nonparametric estimates \hat{F} for each level of accelerating variable; plot on a single probability plot.
- Try to identify a distributional model that fits the data well at all of the stress-levels.

Note: Either the lognormal or the Weibull distribution model provides a reasonable description for the device-A data. But the lognormal distribution provides a better fit to the individual subexperiments.

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ALT Multiple Probability Plot of ML Estimates at Individual Levels of Accelerating Variable

- For each **individual** level of accelerating variable compute the ML estimates.
 - Let T_i be the failure time at temperature Temp_i . For the **lognormal**, $T_i \sim \text{LOGNOR}(\mu_i, \sigma_i)$, assumed model:
 - Compute ML estimates $(\hat{\mu}_i, \hat{\sigma}_i)$.
 - Plot the $\text{LOGNOR}(\hat{\mu}_i, \hat{\sigma}_i)$ cdfs on same plot.
- Assess the commonly used assumption that σ_i does not depend on Temp_i and that Temp_i only affects μ_i .
 - Note:** There are some small differences among the slopes that could be due to sampling error.

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Device-A ALT Lognormal ML Estimation Results at Individual Temperatures

Parameter	ML Estimate	Standard Error	95% Approximate Confidence Interval	
			Lower	Upper
40°C μ	9.81	.42	8.9	10.6
40°C σ	1.0	.27	.59	1.72
60°C μ	8.64	.35	8.0	9.3
60°C σ	1.19	.32	.70	2.0
80°C μ	7.08	.21	6.7	7.5
80°C σ	.80	.16	.55	1.17

The individual loglikelihoods were $L_{40} = -115.46$, $L_{60} = -89.72$, and $L_{80} = -115.58$. The confidence intervals are based on the normal approximation method.

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The Arrhenius-Lognormal Regression Model

The Arrhenius-lognormal regression model is

$$\Pr\{T(\text{temp}) \leq t\} = \Phi_{\text{nor}} \left[\frac{\log(t) - \mu(x)}{\sigma} \right]$$

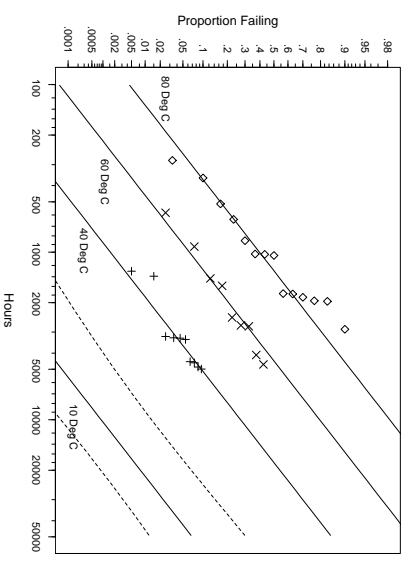
where

- $\mu(x) = \beta_0 + \beta_1 x$,
- $x = 11605/(\text{temp K}) = 11605/(\text{temp } ^\circ\text{C} + 273.15)$,
- $\beta_1 = E_a$ is the activation energy, and
- σ assumed to be constant.

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Lognormal Multiple Probability Plot of the Arrhenius-Lognormal Log-Linear Regression Model Fit to the Device-A ALT Data

$$\widehat{\Pr} \{T(\text{temp}) \leq t\} = \Phi_{\text{nor}} \left[\frac{\log(t) - \hat{\mu}(x)}{\hat{\sigma}} \right], \quad \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1 x$$

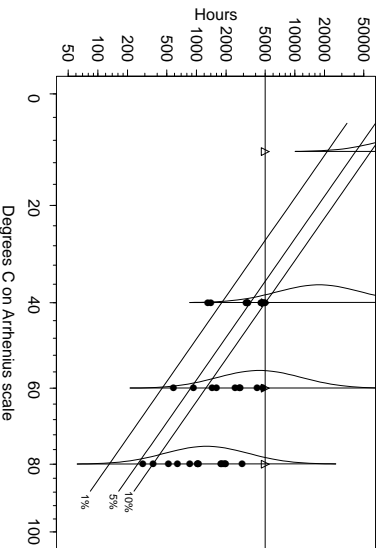


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Scatter plot showing the Arrhenius-Lognormal

Log-Linear Regression Model Fit to the Device-A ALT Data

$$\log[\hat{f}_p(x)] = \hat{\mu}(x) + \Phi_{\text{nor}}^{-1}(p)\hat{\sigma}, \quad \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1 x$$



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ML Estimation Results for the Device-A ALT Data and the Arrhenius-Lognormal Regression Model

Parameter	Estimate	Standard Error	95% Approximate Confidence Intervals	
			Lower	Upper
β_0	-13.5	2.9	-19.1	-7.8
β_1	.63	.08	.47	.79
σ	.98	.13	.75	1.28

The loglikelihood is $\mathcal{L} = -321.7$. The confidence intervals are based on the normal approximation method.

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Analytical Comparison of Individual and Arrhenius-Lognormal Model ML Estimates of Device-A Data

- Distributions fit to individual levels of temperature can be viewed as an **unconstrained model**.
- The Arrhenius-lognormal regression model can be viewed as a **constrained model** (μ linear in x and σ constant).
- Use likelihood ratio test to check for lack of fit with respect to the constraints.

$$\begin{aligned} \mathcal{L}_{\text{unconst}} &= \mathcal{L}_{40} + \mathcal{L}_{60} + \mathcal{L}_{80} = -320.76 \\ \mathcal{L}_{\text{const}} &= -321.7 \end{aligned}$$

- $-2(\mathcal{L}_{\text{const}} - \mathcal{L}_{\text{unconst}}) = -2(-321.7 + 320.76) = 1.88 < \chi^2_{(75,3)} = 4.1$, indicating that there is no evidence of inadequacy of the constrained model, relative to the unconstrained model.

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ALT Multiple Probability Plot of ML Estimates with an Assumed Life/Stress Relationship

- To make inferences at levels of accelerating variable not used in the ALT, use a life/stress relationship to fit all the data.

Let $T(x_i)$ be the failure time at $x_i = 11605/(\text{Temp}_i + 273.15)$. For the, $T(x_i) \sim \text{LOGNOR}(\mu(x_i) = \beta_0 + \beta_1 x_i, \sigma)$, **lognormal** SAFT assumed model:

- ▶ Compute ML estimates $(\hat{\beta}_0, \hat{\beta}_1, \hat{\sigma})$.
- ▶ Plot the $\text{LOGNOR}[\hat{\mu}(x_i) = \hat{\beta}_0 + \hat{\beta}_1 x_i, \hat{\sigma}]$ cdfs on same plot.
- ▶ Plot $\hat{f}_p(x) = \exp[\hat{\beta}_0 + \hat{\beta}_1 x + \Phi_{\text{nor}}^{-1}(p)\hat{\sigma}]$ for various values of p and a range of values of x .

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ML Estimation for the Device-A Lognormal Distribution $F(30,000)$ at 10°C

$$\begin{aligned}\hat{\mu}(x) &= \hat{\beta}_0 + \hat{\beta}_1 x \\ &= -13.469 + .6279 \times 11605 / (10 + 273.15) = 12.2641 \\ \widehat{\zeta}_e &= [\log(t_e) - \hat{\mu}] / \hat{\sigma} = [\log(30,000) - 12.2641] / .9778 \\ &= -2.000\end{aligned}$$

$$\hat{F}(30,000) = \Phi_{\text{nor}}(\widehat{\zeta}_e) = \Phi_{\text{nor}}(-2.000) = .02281$$

$$\hat{\Sigma}_{\hat{\mu}, \hat{\sigma}} = \begin{bmatrix} \widehat{\text{Var}}(\hat{\mu}) & \widehat{\text{Cov}}(\hat{\mu}, \hat{\sigma}) \\ \widehat{\text{Cov}}(\hat{\mu}, \hat{\sigma}) & \widehat{\text{Var}}(\hat{\sigma}) \end{bmatrix} = \begin{bmatrix} .287 & .048 \\ .048 & .0176 \end{bmatrix}$$

$$\begin{aligned}\widehat{\text{se}}_{\hat{F}} &= \frac{\phi(\widehat{\zeta}_e)}{\hat{\sigma}} \left[\widehat{\text{Var}}(\hat{\mu}) + 2\widehat{\zeta}_e \widehat{\text{Cov}}(\hat{\mu}, \hat{\sigma}) + \widehat{\zeta}_e^2 \widehat{\text{Var}}(\hat{\sigma}) \right]^{\frac{1}{2}} \\ &= \frac{\phi(-2.000)}{.9778} \left[.286 + 2 \times (-2.000) \times .047 + (-2.000)^2 \times .0176 \right. \\ &= .0225.\end{aligned}$$

19 - 19

Confidence Interval for the Device-A Lognormal Distribution $F(30,000)$ at 10°C

A 95% normal-approximation confidence interval based on the assumption that $Z_{\logit(\hat{F})} \sim \text{NOR}(0, 1)$ is

$$\begin{aligned}[\underline{F}(t_e), \bar{F}(t_e)] &= \left[\frac{\hat{F}}{\hat{F} + (1 - \hat{F}) \times w}, \frac{\hat{F}}{\hat{F} + (1 - \hat{F})/w} \right] \\ &= \left[\frac{.02281}{.02281 + (1 - .02281) \times w}, \frac{.02281}{.02281 + (1 - .02281)/w} \right] \\ &= [0.032, .14]\end{aligned}$$

where

$$\begin{aligned}w &= \exp\left\{z_{(1-\alpha/2)} \widehat{\text{se}}_{\hat{F}}\right\} / \{\hat{F}(1 - \hat{F})\} \\ &= \exp\{(1.96 \times .0225) / [.02281(1 - .02281)]\} = 7.232.\end{aligned}$$

This wide interval reflects sampling uncertainty when activation energy is unknown. The interval does not reflect model uncertainty. With given activation energy, the confidence intervals would be much narrower.

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Checking Model Assumptions

It is important to check model assumptions by using residual analysis and other model diagnostics

- Define standardized residuals as

$$\exp\left\{\frac{[\log\{t(x_i)\} - \hat{\beta}_0 - \hat{\beta}_1 x_i]}{\hat{\sigma}}\right\}$$

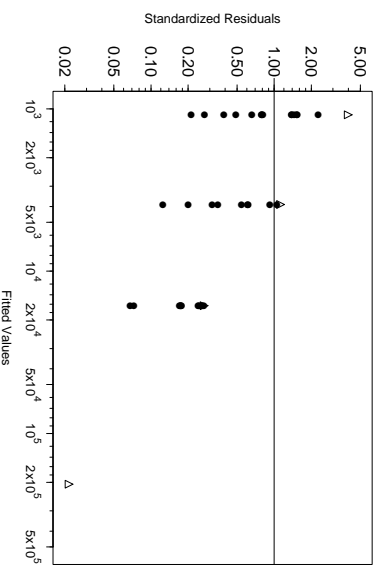
where $t(x_i)$ is a failure time at x_i .

- Residuals corresponding to censored observations are called **censored** standardized residuals.
- Plot residuals versus the fitted values given by $\exp(\hat{\beta}_0 + \hat{\beta}_1 x_i)$.
- Do a probability plot of the residuals.

Note: For the Device-A data, these plots do not conflict with the model assumptions.

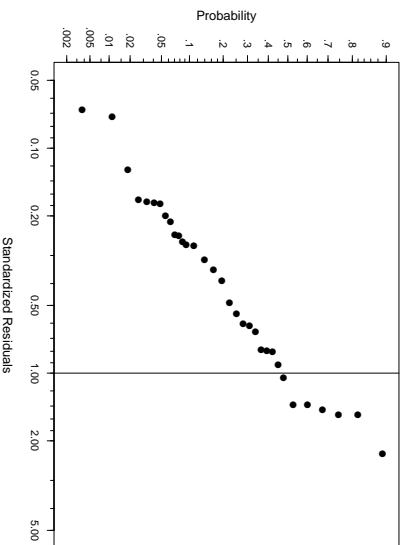
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Plot of Standardized Residuals Versus Fitted Values for the Arrhenius-Lognormal Log-Linear Regression Model Fit to the Device-A ALT Data



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Probability Plot of the Residuals from the Arrhenius-Lognormal Log-Linear Regression Model fit to the Device-A ALT Data



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Some Practical Suggestions

- Build on previous experience with similar products and materials.
- Use pilot experiments; evaluate the effect of stress on degradation and life.
- Seek physical understanding of cause of failure.
- Use results from physical failure mode analysis.
- Seek physical justification for life/stress relationships.
- Design tests to limit the amount extrapolation needed for desired inferences.
- See Nelson (1990).

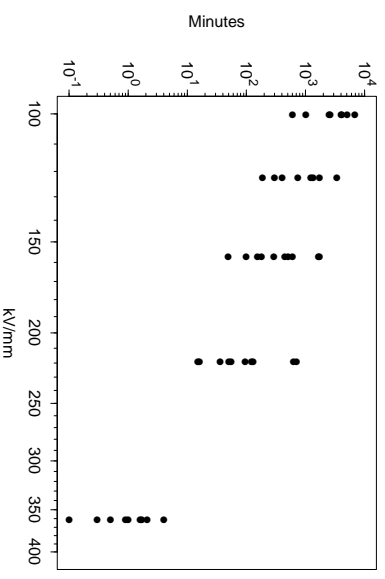
19 - 24

Inferences from AT Experiments

- Inferences or predictions from ATs require important assumptions about:
 - ▶ Focused correctly on relevant failure modes.
 - ▶ Adequacy of AT model for extrapolation.
 - ▶ AT manufacturing/testing processes can be related to actual manufacturing/use of product.
- Important sources of variability usually overlooked.
- Deming would call ATs **analytic studies** (see Hahn and Meeker 1993, *American Statistician*).

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Breakdown Times in Minutes of a Mylar-Polyurethane Insulating Structure (from Kalkanis and Rosso 1989)



19 - 26

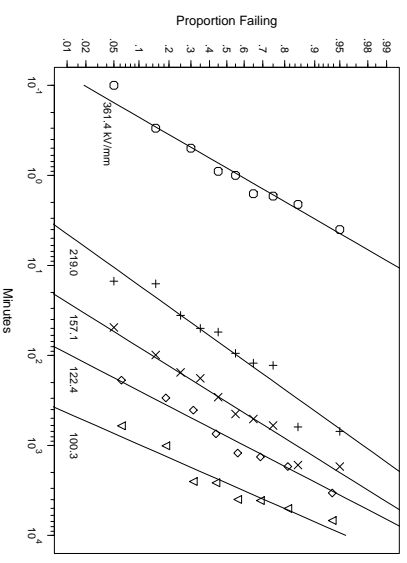
Accelerated Life Test of a Mylar-Polyurethane Laminated Direct Current High Voltage Insulating Structure

- Data from Kalkanis and Rosso (1989)
- Time to dielectric breakdown of units tested at 100.3, 122.4, 157.1, 219.0, and 361.4 kV/mm.
- Needed to evaluate the reliability of the insulating structure and to estimate the life distribution at system design voltages (e.g. 50 kV/mm).
- Except for the highest level of voltage, the relation between log life and log voltage appears to be approximately linear.
- Failure mechanism probably different at 361.4 kV/mm.

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Lognormal Probability Plot of the Individual Tests in the Mylar-Polyurethane ALT

$$\widehat{\Pr}[T(\text{temp}_i) \leq t] = \Phi_{\text{nor}} \left[\frac{\log(t) - \hat{\mu}_i}{\hat{\sigma}_i} \right], \quad i = 100.3, \dots, 361.4$$



19 - 28

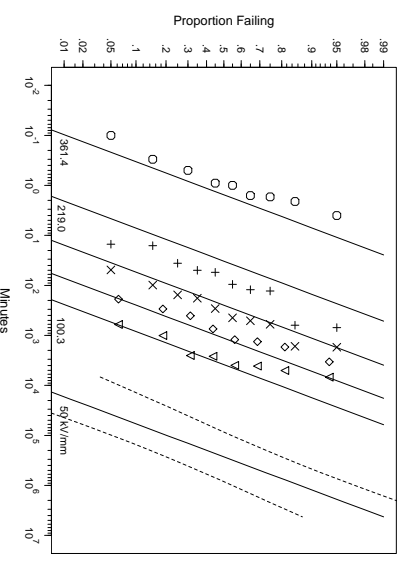
Inverse Power Relationship-Lognormal Model

- The inverse power relationship-lognormal model is

$$F(t) = \Pr[T(\text{vol}t) \leq t] = \Phi_{\text{nor}} \left[\frac{\log(t) - \mu(x)}{\sigma} \right]$$
 where $\mu(x) = \beta_0 + \beta_1 x$, and $x = \log(\text{Voltage Stress})$.
- σ assumed to be constant.

Lognormal Probability Plot of the Inverse Power Relationship-Lognormal Model Fitted to the Mylar-Polyurethane Data Including 361.4 kV/mm

$$\widehat{\Pr}[T(\text{temp}_i) \leq t] = \Phi_{\text{nor}} \left[\frac{\log(t) - \hat{\mu}_i}{\hat{\sigma}_i} \right], \quad i = 100.3, \dots, 361.4$$

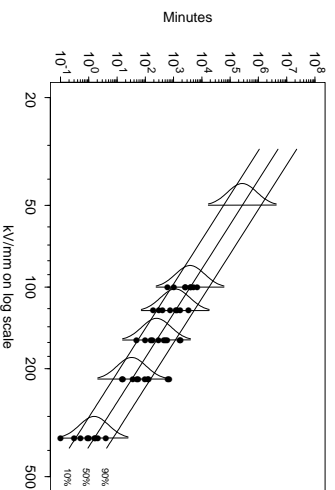


19 - 30

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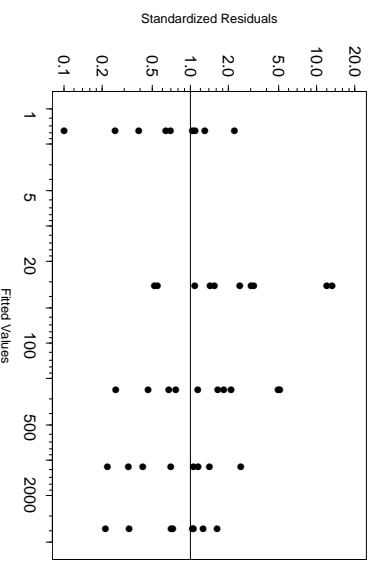
Plot of Inverse Power Relationship-Lognormal Model Fitted to the Mylar-Polyurethane Data Including 361.4 kV/mm

$$\log[\hat{f}_p(x)] = \hat{\mu}(x) + \Phi_{\text{nor}}^{-1}(p)\hat{\sigma}, \quad \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1x$$



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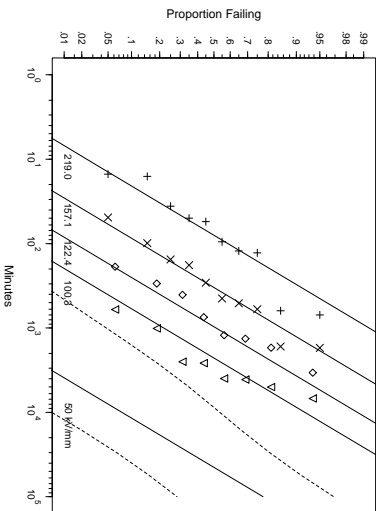
Lognormal Plot of the Standardized Residuals versus $\exp(\hat{\mu}(x))$ for the Inverse Power Relationship-Lognormal Model Fitted to the Mylar-Polyurethane Data with the 361.4 kV/mm Data



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Lognormal Probability Plot of the Inverse Power Relationship-Lognormal Model Fitted to the Mylar-Polyurethane Data W/O the 361.4 kV/mm Data

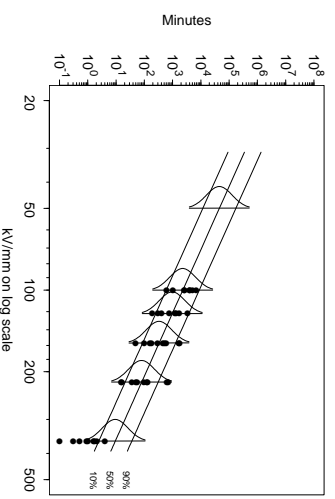
$$\widehat{\Pr} [T(\text{temp}) \leq t] = \Phi_{\text{nor}} \left[\frac{\log(t) - \hat{\mu}(x)}{\hat{\sigma}} \right], \quad \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1x$$



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Plot of Inverse Power Relationship-Lognormal Model Fitted to the Mylar-Polyurethane Data (also Showing 361.4 kV/mm Data Omitted from the ML Estimation)

$$\log[\hat{f}_p(x)] = \hat{\mu}(x) + \Phi_{\text{nor}}^{-1}(p)\hat{\sigma}, \quad \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1x$$



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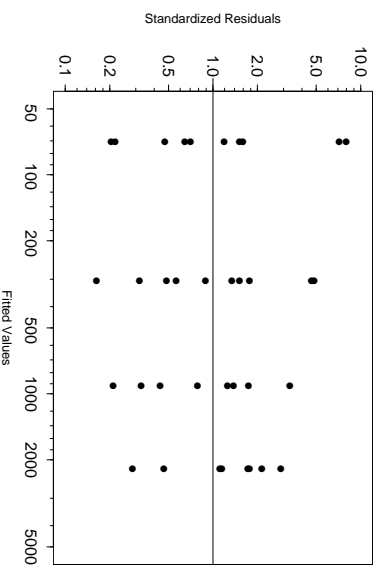
Inverse Power Relationship-Lognormal Model ML Estimation Results for the Mylar-Polyurethane ALT Data

Parameter	ML Estimate	Standard Error	95% Approximate Confidence Intervals	
			Lower	Upper
β_0	27.5	3.0	21.6	33.4
β_1	-4.29	.60	-5.46	-3.11
σ	1.05	.12	.83	1.32

The loglikelihood is $\mathcal{L} = -271.4$. The confidence intervals are based on the normal approximation method.

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Lognormal Plot of the Standardized Residuals versus $\exp(\hat{\mu})$ for the Inverse Power Relationship-Lognormal Model Fitted to the Mylar-Polyurethane Data W/O the 361.4 kV/mm Data



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Analysis of Interval ALT Data on a New-Technology IC Device

- Tests were run at 150, 175, 200, 250, and 300°C.
- Developers interested in estimating activation energy of the suspected failure mode and the long-life reliability.
- Failures had been found only at the two higher temperatures.
- After early failures at 250 and 300°C, there was some concern that no failures would be observed at 175°C before decision time.
- Thus the 200°C test was started later than the others.

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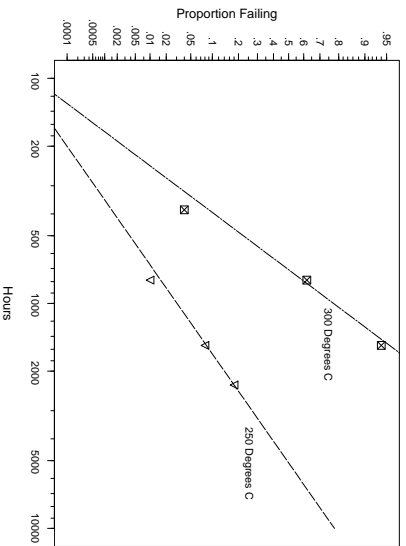
New-Technology IC Device ALT Data

Hours	Status		Number of Devices		Temperature °C
	Lower	Upper	Right Censored	Left Censored	
1536	Right Censored		50		150
1536	Right Censored		50		175
96	Right Censored		50		200
384	Failed		1		250
788	Failed		3		250
1536	Failed		5		250
2304	Failed		5		250
2304	Right Censored			41	250
192	Failed			4	300
384	Failed			27	300
788	Failed			16	300
1536	Failed			16	300
1536	Right Censored		3		300

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Lognormal Probability Plot of the Failures at 250 and 300°C for the New-Technology Integrated Circuit Device ALT Experiment

$$\widehat{\Pr} [T(\text{temp}_i) \leq t] = \Phi_{\text{nor}} \left[\frac{\log(i) - \hat{L}_i}{\hat{\sigma}_i} \right], \quad i = 250, 300$$



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Individual Lognormal ML Estimation Results for the New-Technology IC Device

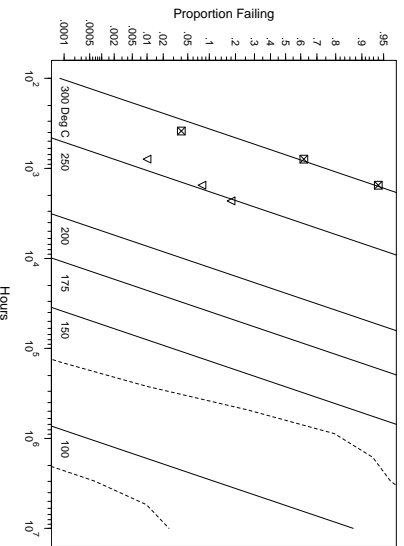
Parameter	ML Estimate	Standard Error	95% Approximate Confidence Intervals	
			Lower	Upper
250°C	μ	8.54	.33	7.9
	σ	.87	.26	.48
				1.57
300°C	μ	6.56	.07	6.4
	σ	.46	.05	.36
				.58

The loglikelihood were $L_{250} = -32.16$ and $L_{300} = -53.85$. The confidence intervals are based on the normal approximation method.

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Lognormal Probability Plot Showing the Arrhenius-Lognormal Model ML Estimation Results for the New-Technology IC Device

$$\widehat{\Pr} [T(\text{temp}) \leq t] = \Phi_{\text{nor}} \left[\frac{\log(t) - \hat{\mu}(x)}{\hat{\sigma}} \right], \quad \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1 x$$



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Arrhenius-Lognormal Model ML Estimation Results for the New-Technology IC Device

Parameter	ML Estimate	Standard Error	95% Approximate Confidence Intervals	
			Lower	Upper
β_0	-10.2	1.5	-13.2	-7.2
β_1	.83	.07	.68	.97
σ	.52	.06	.42	.64

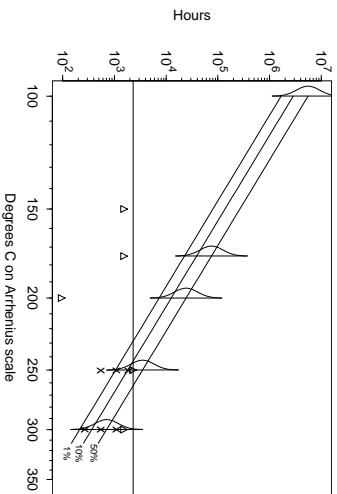
The loglikelihood is $L = -88.36$.

Comparing the constrained and unconstrained models $L_{\text{unconst}} = L_{250} + L_{300} = -86.01$ and for the constrained model, $L_{\text{const}} = -88.36$. The comparison has just one degree of freedom and $-2(-88.36 + 86.01) = 4.7 > \chi^2_{(95,1)} = 3.84$, again indicating that there is some lack of fit in the constant- σ Arrhenius-lognormal model.

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Arrhenius Plot Showing ALT Data and the Arrhenius-Lognormal Model ML Estimation Results for the New-Technology IC Device.

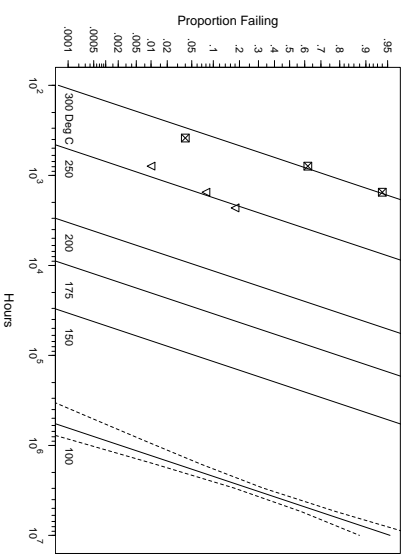
$$\log[\hat{p}_p(x)] = \hat{\mu}(x) + \Phi_{\text{nor}}^{-1}(p)\hat{\sigma}, \quad \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1 x$$



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Lognormal Probability Plot Showing the Arrhenius-Lognormal Model ML Estimation Results for the New-Technology IC Device with Given $E_a = .8$

$$\widehat{\text{Pr}}[T(\text{temp}) \leq t] = \Phi_{\text{nor}} \left[\frac{\log(t) - \hat{\mu}(x)}{\hat{\sigma}} \right], \quad \hat{\mu}(x) = \hat{\beta}_0 + E_a x$$



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Pitfall 1: Multiple (Unrecognized) Failure Modes

- High levels of accelerating factors can induce failure modes that would not be observed at normal operating conditions (or otherwise change the life-acceleration factor relationship).
- Other failure modes, if not recognized in data analysis, can lead to incorrect conclusions.
- Suggestions:
 - ▶ Determine failure mode of failing units.
 - ▶ Analyze failure modes separately.

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Pitfall 2: Failure to Properly Quantify Uncertainty

- There is uncertainty in statistical estimates.
- Standard statistical confidence intervals quantify uncertainty arising from **limited data**.
- Confidence intervals **ignore model uncertainty** (which can be tremendously amplified by extrapolation in Accelerated Testing).
- Suggestions:
 - ▶ Use confidence intervals to quantify statistical uncertainty.
 - ▶ Use sensitivity analysis to assess the effect of departures from model assumptions and uncertainty in other inputs.

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Pitfall 3: Multiple Time Scales

- Composite material
 - ▶ Chemical degradation over time changes material ductility.
 - ▶ Stress cycles during use lead to initiation and growth of cracks.
- Incandescent light bulbs
 - ▶ Filament evaporates during burn time.
 - ▶ On-off cycles induce thermal and mechanical shocks that can lead to fatigue cracks.
- Inkjet pen
 - ▶ Real time (corrosion)
 - ▶ Characters or pages printed (ink supply, resistor degradation).
 - ▶ On/off cycles of a print operation (thermal cycling of substrate and printhead lamination).

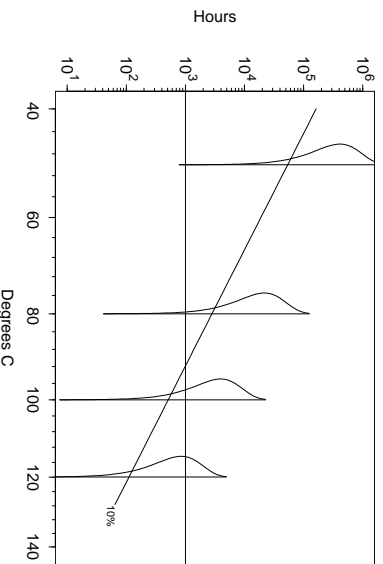
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Dealing with Multiple Time Scales

- Suggestions:
- Need to use the appropriate time scale(s) for evaluation of each failure mechanism.
 - With multiple time scales, understand ratio or ratios of time scales that arise in actual use.
 - Plan ATs that will allow effective prediction of failure time distributions at desired ratio (or ratios) of time scales.

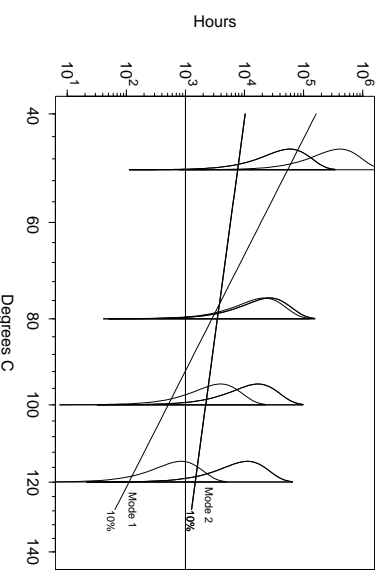
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Temperature-Accelerated Life Test for an IC Device



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Unmasked Failure Mode with Lower Activation Energy for an IC Device



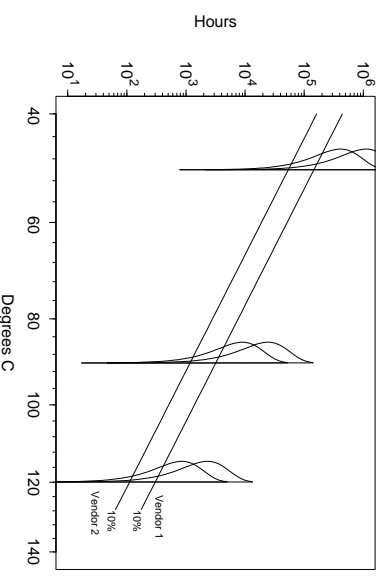
19 - 50

Pitfall 4: Masked Failure Mode

- Accelerated test may focus on one known failure mode, masking another!
- Masked failure modes may be the first one to show up in the field.
- Masked failure modes could dominate in the field.
- Suggestions:
 - ▶ Know (anticipate) different failure modes.
 - ▶ Limit acceleration and test at levels of accelerating variables such that each failure mode will be observed at two or more levels of the accelerating variable.
 - ▶ Identify failure modes of all failures.
 - ▶ Analyze failure modes separately.

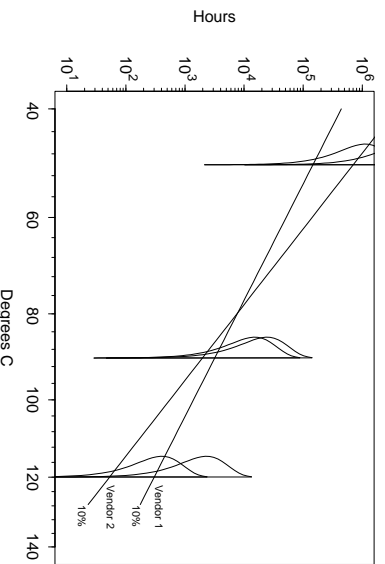
19 - 51

Comparison of Two Products I Simple Comparison



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Comparison of Two Products II Questionable Comparison



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Pitfall 5: Faulty Comparison

- It is sometimes claimed that Accelerated Testing is not useful for predicting reliability, but is useful for comparing alternatives.
- Comparisons can, however, also be misleading.
- Beware of comparing products that have different kinds of failures.
- Suggestions:
 - ▶ Know (anticipate) different failure modes.
 - ▶ Identify failure modes of all failures.
 - ▶ Analyze failure modes separately.
 - ▶ Understand the physical reason for any differences.

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Pitfall 6: Acceleration Factors Can Cause Deceleration!

- Increased temperature in an **accelerated** circuit-pack reliability audit resulted in fewer failures than in the field because of lower humidity in the **accelerated** test.
- Higher than usual use rate of a mechanical device in an accelerated test inhibited a corrosion mechanism that eventually caused serious field problems.
- Automobile air conditioners failed due to a material **drying out** degradation, lack of use in winter (not seen in continuous accelerated testing).
- Inkjet pens fail from infrequent use.
- **Suggestion**: Understand failure mechanisms and how they are affected by experimental variables.

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Pitfall 7: Untested Design/Production Changes

- Lead-acid battery cell designed for 40 years of service.
- New epoxy seal to inhibit **creep** of electrolyte up the positive post.
- Accelerated life test described in published article **demonstrated** 40 year life under normal operating conditions.
- 200,000 units in service after 2 years of manufacturing.
- First failure after 2 years of service; third and fourth failures followed shortly thereafter.
- Improper epoxy cure combined with charge/discharge cycles hastened failure.
- Entire population had to be replaced with a re-designed cell.

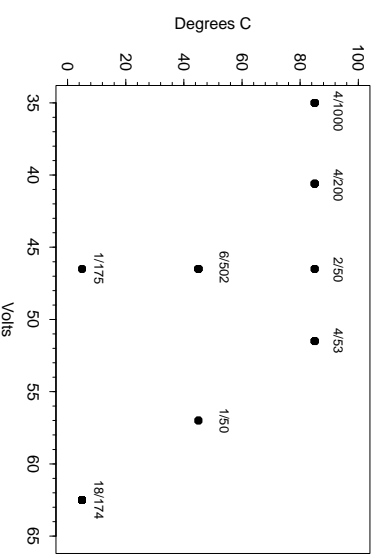
19 - 56

Temperature/Voltage ALT Data on Tantalum Electrolytic Capacitors

- Two-factor ALT
- Non-rectangular unbalanced design
- Much censoring
- The Weibull distribution seems to provide a reasonable model for the failures at those conditions with enough failures to make a judgment.
- Temperature effect is not as strong.
- Data analyzed in Singpurwalla, Castellino, and Goldschen (1975)

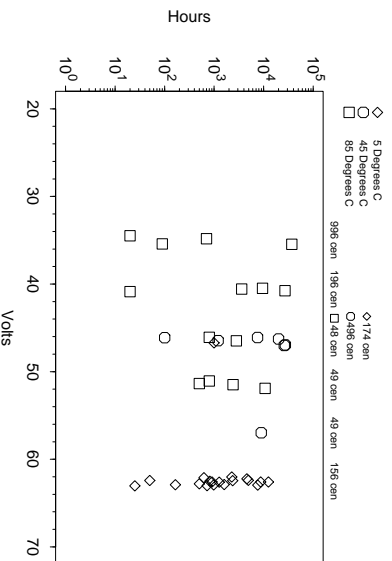
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Tantalum Capacitors ALT Design Showing Fraction Failing at Each Point



19 - 58

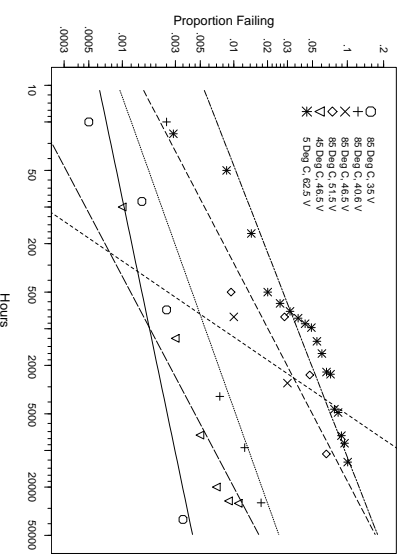
Scatter Plot of Failures in the Tantalum Capacitors ALT Showing Hours to Failure Versus Voltage with Temperature Indicated by Different Symbols



19 - 59

Weibull Probability Plot for the Individual Voltage and Temperature Level Combinations for the Tantalum Capacitors ALT, with ML Estimates of Weibull cdfs

$$Pr [T(\text{temp}_i) \leq t] = \Phi_{\text{seV}} \left[\frac{\log(t) - \mu_i}{\sigma_i} \right]$$



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Tantalum Capacitors ALT Weibull/Arrhenius/Inverse Power Relationship Models

- Model 1: $\mu(x) = \beta_0 + \beta_1 x_1 + \beta_2 x_2$
- Model 2: $\mu(x) = \beta_0 + \beta_1 x_1 + \beta_2 x_2 + \beta_3 x_1 x_2$
- where $x_1 = \log(\text{volt})$, $x_2 = 11605/(\text{temp K})$, and $\beta_2 = E_a$.
- Coefficients of the regression model are highly sensitive to whether the interaction term is included in the model or not (because of the nonrectangular design with highly unbalanced allocation).
- Data provide no evidence of interaction.
- Strong evidence for an important voltage effect on life.

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Tantalum Capacitor ALT Weibull-Inverse Power Relationship Regression ML Estimation Results

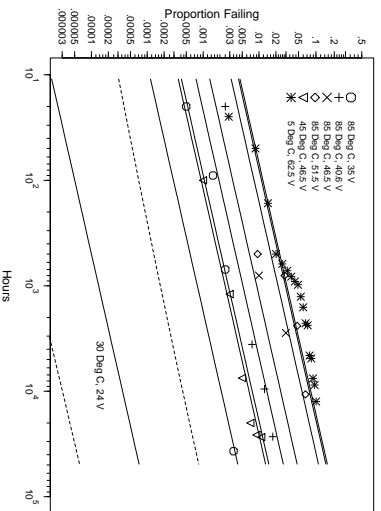
Parameter	ML Estimate	Standard Error	95% Approximate Confidence Interval	
			Lower	Upper
Model 1 β_0	84.4	13.6	57.8	111.
β_1	-20.1	4.4	-28.8	-11.4
β_2	.33	.19	-.04	.69
σ	2.33	.36	1.72	3.16
Model 2 β_0	-78.6	109.0	-292.3	135.1
β_1	19.9	26.7	-32.5	72.35
β_2	5.13	3.3	-1.35	11.6
β_3	-1.17	.80	-2.8	.40
σ	2.33	.36	1.72	3.16

Loglikelihoods $\mathcal{L}_1 = -539.63$ and $\mathcal{L}_2 = -538.40$

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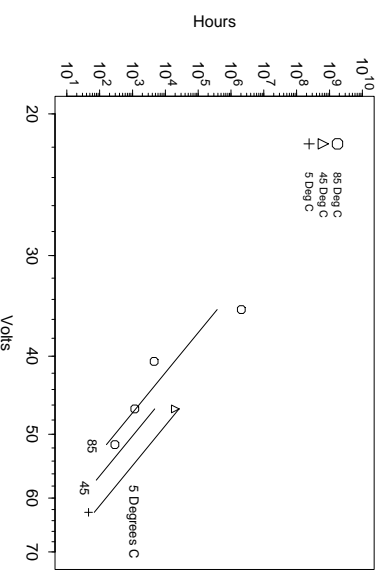
Weibull Multiple Probability Plot of the Tantalum Capacitor ALT Data Arrhenius-Inverse Power Relationship Weibull Model (with no Interaction)

$$Pr \{T(\text{temp}) \leq t\} = \Phi_{\text{sev}} \left[\frac{\log(t) - \hat{\mu}(x)}{\hat{\sigma}} \right], \hat{\mu}(x) = \hat{\beta}_0 + \hat{\beta}_1 x_1 + \hat{\beta}_2 x_2$$



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ML Estimates of $t_{0.01}$ for the Tantalum Capacitor Life Using the Arrhenius-Inverse Power Relationship Weibull Model



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Other Topics in Chapter 19

Discussion of

- Highly accelerated life tests (HALT).
- Environmental stress and STRIFE testing.
- Burn-in.
- Environmental stress screening.

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